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United States Patent [19]
Matsumura

[11] **Patent Number: Des. 421,968**
[45] **Date of Patent: ** Mar. 28, 2000**

[54] **CONTACTOR FOR SEMICONDUCTOR IC TESTERS**

D. 305,224 12/1989 Iwashita D13/147
D. 312,816 12/1990 Huang D13/147
D. 404,710 1/1999 Lai et al. D13/147

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[73] Assignee: **Advantest Corporation**, Japan

[**] Term: **14 Years**

[57] **CLAIM**

[21] Appl. No.: **29/095,314**

The ornamental design for a contactor for semiconductor IC testers, as shown and described.

[22] Filed: **Oct. 20, 1998**

DESCRIPTION

[30] **Foreign Application Priority Data**

Apr. 21, 1998 [JP] Japan 10-11416
Apr. 21, 1998 [JP] Japan 10-11417
Apr. 21, 1998 [JP] Japan 10-11418

FIG. 1 is a perspective view of a contactor for semiconductor IC testers showing my new design;
FIG. 2 is a top plan view in a reduced scale of FIG. 1;
FIG. 3 is a bottom plan in a reduced scale of FIG. 1;
FIG. 4 is a front elevational view in a reduced scale of FIG. 1, the rear elevational view being a mirror image of the front elevational view;
FIG. 5 is a left side elevational view in a reduced scale of FIG. 1, the right side elevational view being a mirror image of the left side elevational view; and,
FIG. 6 is an enlarged center horizontal cross-sectional view of FIG. 2.

[51] **LOC (6) Cl.** **13-03**

[52] **U.S. Cl.** **D13/182; D13/147**

[58] **Field of Search** D13/147, 182,
D13/184; D10/75; 257/48, 690, 692, 693,
697

[56] **References Cited**

U.S. PATENT DOCUMENTS

D. 239,006 3/1976 Kelley D10/75

1 Claim, 1 Drawing Sheet

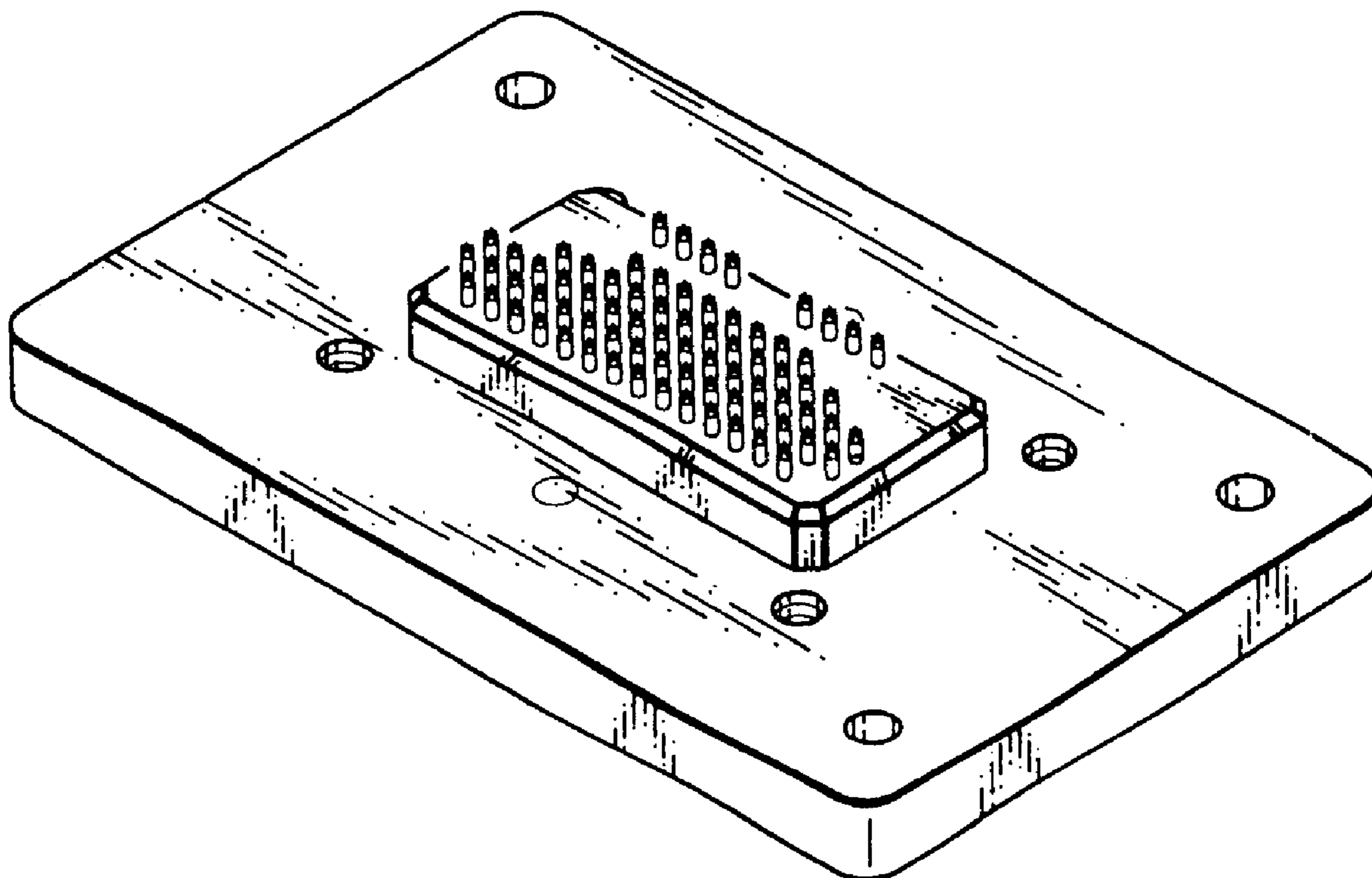


Fig.1

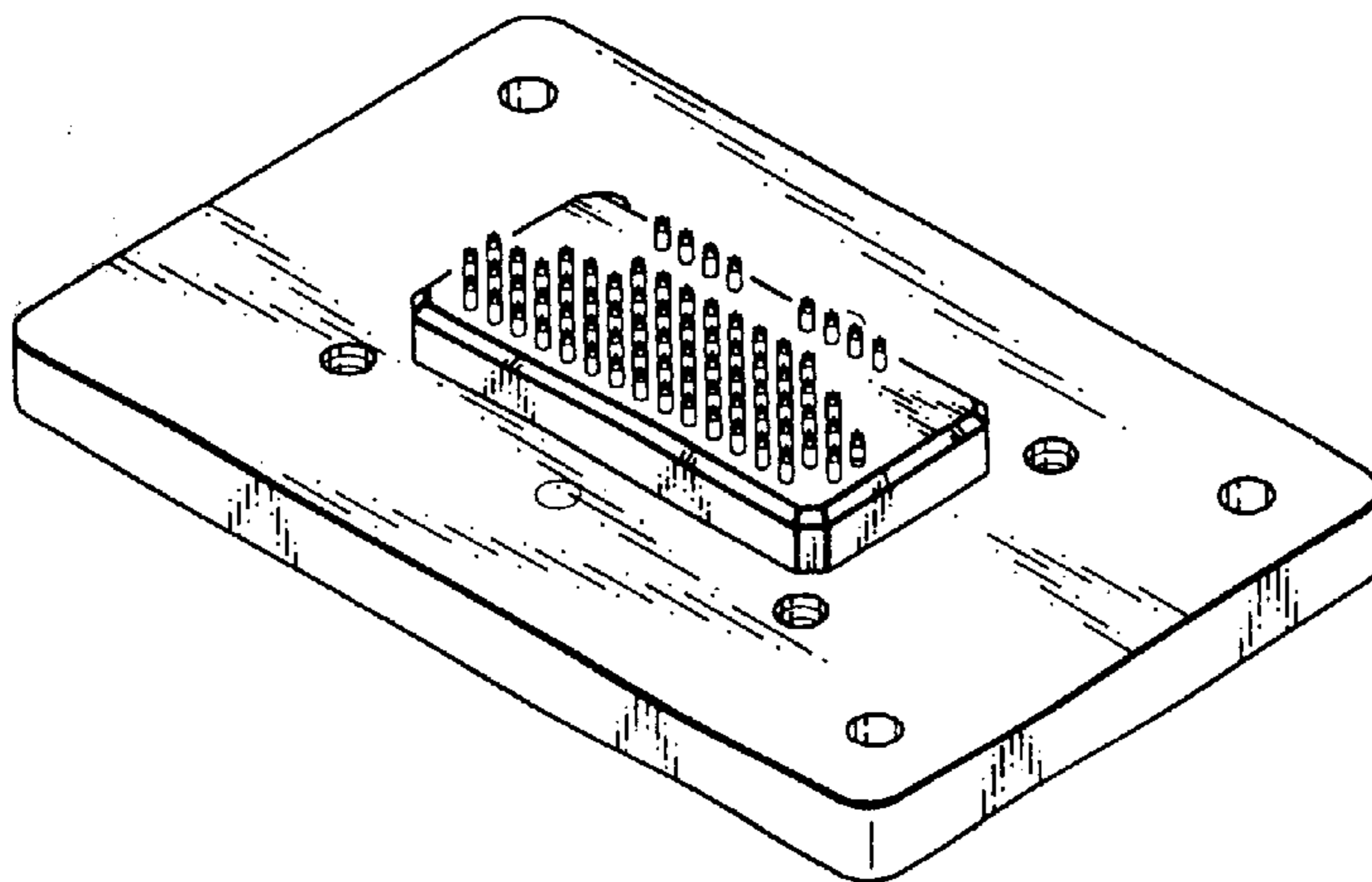


Fig.2

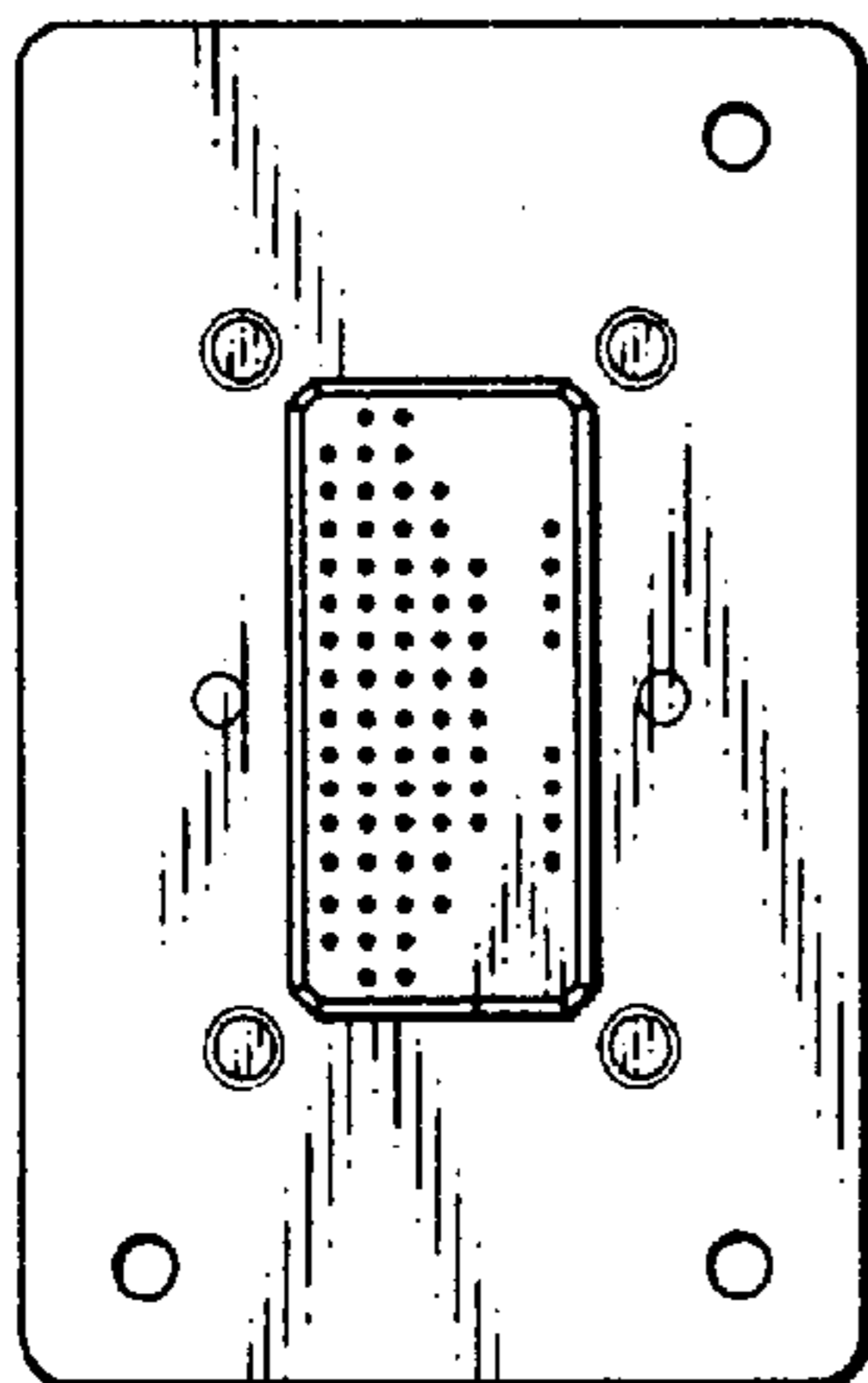


Fig.3

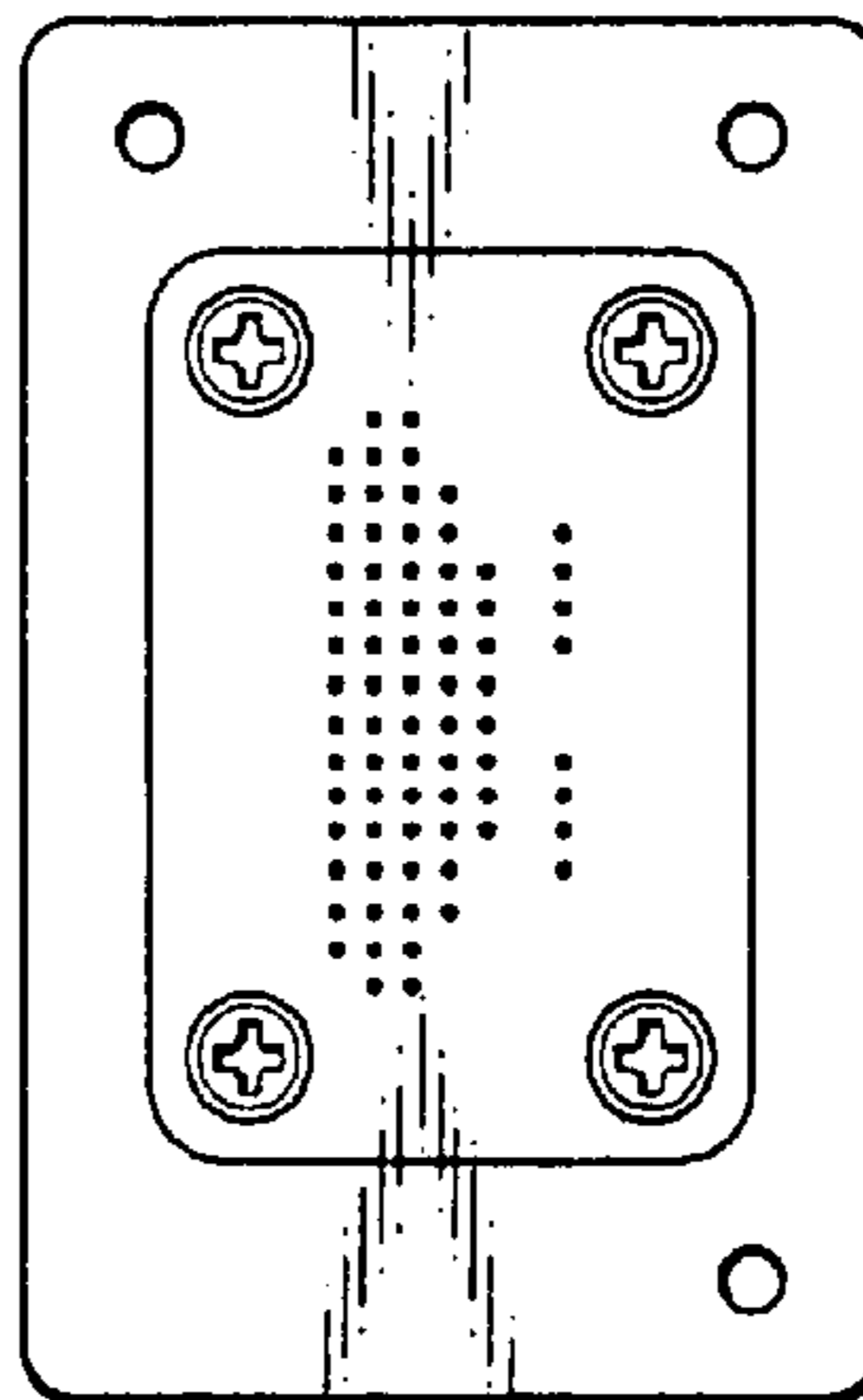


Fig.4



Fig.5

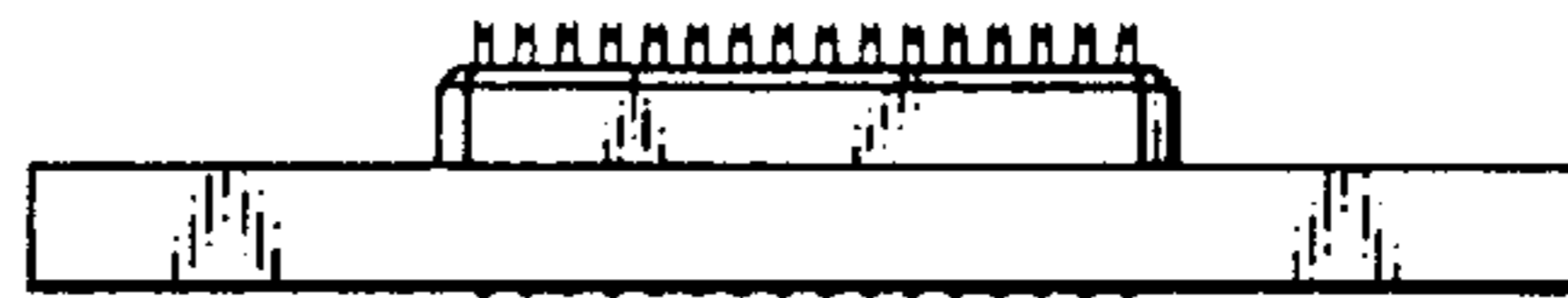


Fig.6

